IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicants: Chin et al.

Case: 5017/ISM/CORE/MCVD/SB

Serial No.: 09/917,842

Filed: July 27, 2001

Examiner: Kosowski, Alexander J. Group Art Unit: 2125

Confirmation No : 3573

Title: ATOMIC LAYER DEPOSITION APPARATUS

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

AMENDMENT UNDER 37 C.F.R. §1.312

Please enter this amendment and reconsider the claims pending in the application for reasons discussed below. Although the Applicants believe that no fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782 for any fees. including extension of time fees, and any other fees required to make this response timely and acceptable to the Office.